

IFW



Attorney Docket No. 9409-3

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Robert P. Freese et al.

Confirmation No.: 8346

Application No.: 10/661,917

Group Art Unit: 2811

Filed: September 11, 2003

For: SYSTEMS AND METHODS FOR MASTERING MICROSTRUCTURES
THROUGH A SUBSTRATE USING NEGATIVE PHOTORESIST AND
MICROSTRUCTURE MASTERS SO PRODUCED

June 29, 2004

Mail Stop Amendment
Commissioner for Patents
Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Please enter the following Preliminary Amendment before examination of the present application.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.